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Atty. Docket No. PIA31069/ANS

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

:

Sang Hun OH

: GROUP ART UNIT: 3749

APPLICATION NO: 10/751,184

:

FILED: DECEMBER 30, 2003

: EXAMINER: GRAVINI, Stephen M.

FOR: METHOD FOR ETCHING A
METAL LAYER IN A
SEMICONDUCTOR DEVICE

I hereby certify that this document is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 1, 2005.

By:


Jennie HeatonAMENDMENT AND REQUEST FOR RECONSIDERATION UNDER 35 U.S.C. 132
AND 37 C.F.R. 1.111

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SIR:

Responsive to the Office Action dated July 21, 2004, Applicant respectfully requests reconsideration of the above-identified application in view of the following amendments and remarks.